

Substitute for form 1449/PTO		Complete If Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>		Application Number	10/733,523-Conf. #9060
		Filing Date	December 10, 2003
		First Named Inventor	Kevin L. Beaman
		Art Unit	1762
		Examiner Name	D. P. Turocy
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		Attorney Docket Number	108298718US

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